

Search Notes

Application/Control No.

10/527,314

Examiner

Zoila E. Cabrera

Applicant(s)/Patent under
Reexamination

RIETSCHEL, JOHANNES

Art Unit

2125

SEARCHED

Class Subclass Date Examiner

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above Search { 3/16/06 L
updated }

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

DATE EXMR

INTERFERENCE SEARCHED

Class Subclass Date Examiner
